

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	46054	psm or (((phase adj shift) or (phase-shift)) adj mask) or photomask or (photo-mask) or (photo adj mask)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/29 09:47
L2	593893	offset	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/29 09:47
L3	21804	(target or wafer or cathode or substrate) with 2	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/29 09:47
L4	115	1 same 3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/29 09:50
L5	194729	sputter\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/29 09:50
L6	93	(1 same 5) and 3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2004/11/29 09:50